



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Yasunori Ito, et al.  
Serial No.: 10/640,850  
Filed: August 13, 2003  
For: METHOD OF PRODUCING  
CERAMIC THERMISTOR  
CHIPS  
Group Art Unit: 1742  
Examiner: H. D. Wilkins III  
Attorney Docket: MURTP083D1

**CERTIFICATE OF MAILING**

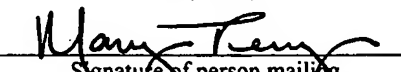
Date of Deposit: November 19, 2007

I hereby certify that this correspondence is, on  
the date shown above, being:

deposited with the United States Postal Service  
with sufficient postage as first class mail in an  
envelope addressed to: Commissioner for  
Patents, Alexandria, Virginia 22313-1450.

Typed or printed name of person mailing:

Mary Terry

  
Signature of person mailing

**AMENDMENT "F" AFTER FINAL ACTION**

Mail Box: AF  
Commissioner for Patents  
Alexandria, Virginia 22313-1450

*Do Not Enter  
Larry Wilkins*

Sir:

In response to the Final Office Action dated September 20, 2007 in the above-  
referenced application, applicant amends the application as follows: